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TITLE: Method and apparatus for investigating a sample

under tension

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PARENT-CASE:

BACKGROUND OF THE INVENTION This application is a

continuation-in-part

application of the U.S. application Ser. No. 746,096.

FOREIGN-APPL-PRIORITY-DATA:

FOREIGN-PRIORITY-APPL-NO: DE 3509163

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BSPR:

German Auslegeschrift No. 26 31 663 teaches the zero contact measurement of

relative changes in length of a sample on the basis of comparative measurements

of travel time of laser reflections during continuous scanning of the total

measured length of the sample, whereby a light beam is split by a beam

splitter, with one portion of the beam of light being directed to the sample

and then detected by a photodetector, and the other portion of the beam

directed by an adjustable reference **diaphragm** to a second similar

photodetector. Repeated scanning of the zone of different reflectivity of the

object being measured is required for evaluation in order to obtain any

measurement results at all. For this reason, the method does not exhibit

sufficient time resolution and, in particular, does not permit immediate

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detection of rapid sudden changes in length, so that this method, too, cannot

be used for rapid pulling or tearing tests. Moreover, the method allows

determination of only an average change in lenght over the total measurement

area, and not different stretching behavior in different areas of the sample,

especially not the three-dimensional distribution of stretching over the

sample, something which is important because a sample is not necessarily

subjected to equal changes in length in all of its areas when the same tensile

stress is applied, but can exhibit different distributions.

BSPR:

A zero-contact optical measuring method using a cathetometer is described in

"Messtechnische Briefe" Vol. 13 No. 2, Page 25-31, 1977 wherein markings made

on the samples are scanned with the aid of an optical aiming device by the

operator and the distances between the markings are measured by a linear

measurement system built into the cathetometer. This is a subjective measuring

method involving observation, with the adjustments being made by the operator $% \left(1\right) =\left(1\right) +\left(1$

on the basis of the observation possibly being further automatically processed.

The subjective decision on the part of the operator is involved in the

measuring process. In addition, the known method does not permit any dynamic

pulling tests but only creep tests. In addition, only measurements of

lengthwise stretching can be conducted.

DEPR:

According to the invention an apparatus is provided which includes a housing 1

accommodating an illuminating device 2 comprising, for example an ellipsoid

lamp 3, a **diaphragm** 4, preferably with a volume scattering disk, a lens 6, and

an exit diaphragm 7. A receiving unit 11 with a shading

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diaphragm, a focusing

lens 12, and a photodiode 13 mounted on a holder are disposed outside of the

housing 1 at a distance therefrom on the optical axis determined by the

illuminating device 2. The sample under tension 21 is placed between

illuminating device 2 and receiving unit 11.

DEPR:

In the given arrangement, the cylindrical lens also causes the light beam to be

guided during the scanning produced by the rotating mirror so to speak parallel

to itself over the sample under tension beneath the pattern mounted on it.

Laser beam 33 is reflected from the pulling sample 21. Accordingly, an

additional receiving device 38 is provided in the housing, which has among

other things a lens 41 as well as a photodiode 39. The signals detected by the

two photodiodes 13 and 39 are fed to an electronic circuit 51 where they are

processed in a manner to be described hereinbelow. The light from lamp 3 is

diffusely scattered by a volume-scattering disk 14 in such fashion that the

intensity of the light illuminating sample 21 is largely homogeneous, in other

words every point on the sample is illuminated in the lengthwise and transverse

directions with essentially the same light intensity in order to obtain a

signal which is as linear as possible. Double <u>diaphragm</u> 4 is associated

directly with scattering disk 14, with the <u>diaphragm</u> 4 including two <u>diaphragm</u>

slits 16, through which the light from lamp 3 is broken into two partial bands,

which are rendered parallel by lens 6, whereby the edges of the light beams can

be blocked out by additional <u>diaphragm</u> 7. Accordingly, two light bands 17

(FIG. 3) fall on sample 21 and the shading <u>diaphragm</u> 18 located located

directly behind the sample 21. As can be seen from FIG. 3

in particular, the amount of light from the two light bands 17 which passes between sample 21 and shading diaphragm 18 is linearly dependent on the width of the sample, which contracts when the sample is subjected to transverse tension. Calibration can be done if shading diaphragm 18 is adjustable and sample 21 is so adjusted in the relaxed state that no light falls between shading diaphragm 18 and sample 21. The amount of light that passes between sample 21 and shading diaphragm 18 during tension is focused by a focusing lens 12 on photodiode 13 and initially converted into a current which is proportional to the light intensity. The

photodiode is biased in the blocking direction whereby the barrier capacitance

is simultaneously reduced making possible a more rapid response. By connecting

a resistance in series with a photodiode, the photocurrent is converted into a

decreasing proportional voltage through the resistor, whereby the value of the

resistor determines the sensitivity of the arrangement. The additional

electronic circuit initially essentially includes an amplifier and an

electrometer subtractor for zero balancing to exclude ambient light.

DEPR:

The pulling device, not shown in greater detail, comprises clamping devices 23

for firmly clamping the sample 21. The sample 21 (FIG. 5a) comprises a central

part 24 and gripping parts or shoulders 26 which are broadened at both ends

thereof, to which shoulders the clamping devices 23 are attached. In addition,

a transverse pattern 27 with a different absorptivity and therfore reflectivity

or scattering power similar to a bar code, is mounted on one side of the sample

21 in middle part 24. A transverse pattern 27 can be printed, for example, by

screen printing. The sample itself consists of any material whose longitudinal stretching in a stretching test is to be investigated, especially in a rapid tearing test. The sample 21 is pulled apart in such a test by a pulling device equipped with clamping devices 23 in the direction of arrrow F. It is evident from a comparision between FIG. 5a and FIG. 5 that the pattern segments increase their spacing as the sample is pulled whereby the frequency of the intensity, modulated by pattern 27, of the reflected light is changed by a beam that uniformly scans the sample, i.e. with constant scanning frequency.

CLPR: 17. An apparatus for measuring a lateral contraction of a test piece having a transverse pattern with a reflectivity differing from the test piece elongated by a drawing device including a device for measuring a lateral contraction of the test piece, the apparatus comprising a light source means arranged upstream of the test piece, said light source means including imaging optic means, a diaphragm plate means disposed downstream of the test piece for defining a

narrow strip of light from the light source means, and a light detector means

positioned downstream of the diaphragm and disposed on an optical axis defined

by the light source means, the imaging optic means, and the test piece.